



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Applicant : Caibin Xiao, et al.
Serial No. : 10/717,154
Filed : November 19, 2003
TC/Art Unit : 2859
Examiner : Gail Kaplan Verbitsky
Title : **A Deposition Sensor Based on Differential Heat Flux Measurement**
Docket No. : 020354 075P2
Customer No.: 33805

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir or Madam:

AMENDMENT

Kindly amend the above identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

Please charge any fee necessary or due to assure entry to:

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